

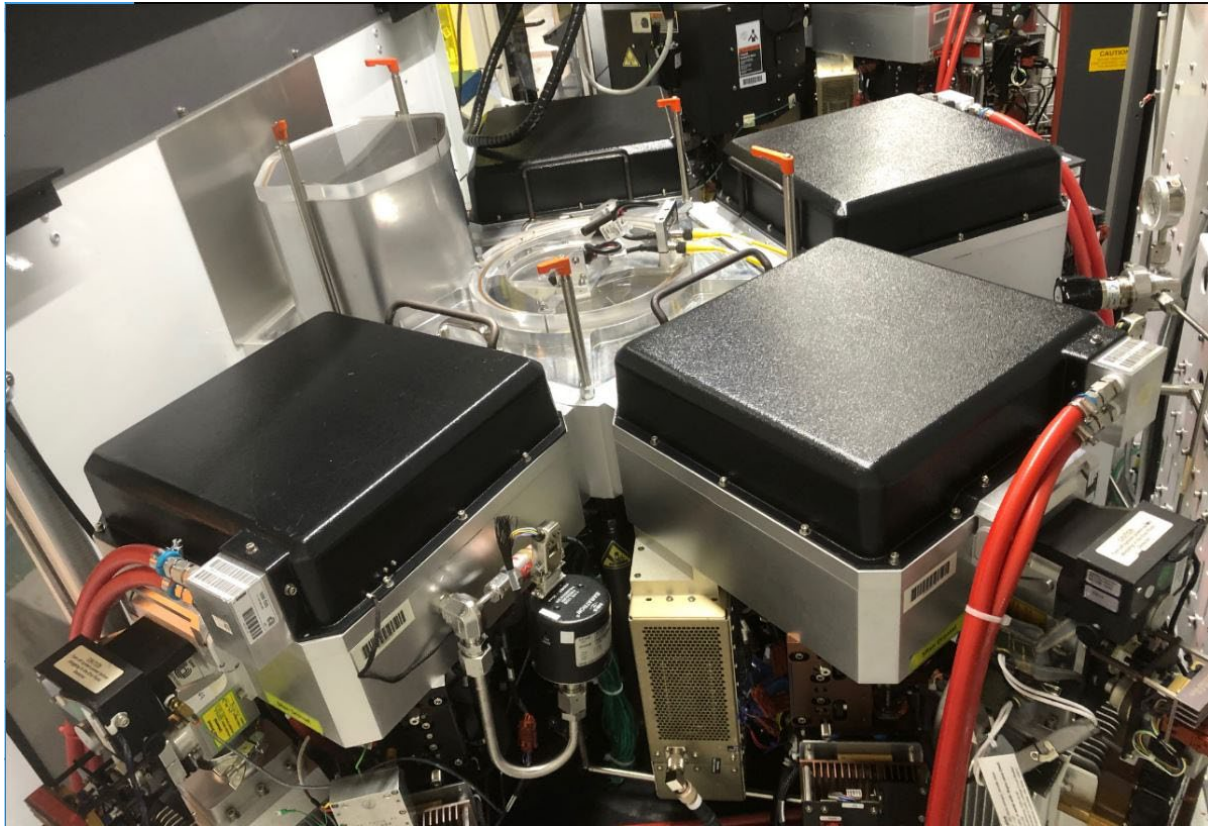
<b>Manufacturer</b>	Applied Materials
<b>Model</b>	P5000
<b>Cassette to Cassette</b>	YES
<b>Accessories</b>	We sell the whole tool.
<b>CE Marked</b>	YES
<b>Year of Manufacture</b>	2001
<b>Condition</b>	Very Good
<b>Serial Number(s)</b>	

8 inch tool with 4 CVD chambers.

Tool still in Production until (Planned until 3.23















25-Oct-2020

Applied Materials Precision 5000-

9:25:15

System Wafer Chamber A Chamber B Chamber C Chamber D Program Service

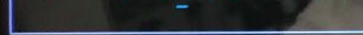
Monitor Handler

Chamber A: CVD



Chamber C: CVD

Clean KO CLN SILANE  
Step 6(SET-UP) 30/ 3 s  
1198scc, 2800/ 2.01 T  
Running process steps



Monitor Wafer Screen

Loadlock Chamber  
Pressure: 416 mTorr

Top  
B:13  
B:14  
B:15  
B:16  
B:9  
B:10  
B:11  
B:12  
Elevator

Top



Elevator

Control Handler

Chamber B: CVD



Chamber D: CVD

Clean KO CLN SILANE  
Step 4(OVERET) 29/ 15 s  
2243scc, 2000/ 2.16 T  
780/ 778/ 9 W



Top



Lot : 246533702S05

Lot :  
Open Door Shuttle Cassettes

Clamp A Clamp B F-A Prev

